



Docket No. 7407562435

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of: )  
Hirokazu YAMAGATA et al. ) Group Art Unit: 2823  
Serial No. 10/073,284 ) Examiner: S. Foong  
Filed: February 13, 2002 )  
For: **LIGHT EMITTING DEVICE AND** ) Date: November 21, 2002  
**METHOD OF MANUFACTURING THE** )  
**SAME** )

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**CERTIFICATE OF MAILING**

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231, on November 21, 2002.

Adele Stamper  
Adele Stamper

**RESPONSE TO RESTRICTION REQUIREMENT  
AND AMENDMENT**

Commissioner for Patents  
Washington, D.C. 20231

Sir:

In response to the Office Action mailed October 21, 2002, please amend the application as follows:

**IN THE CLAIMS:**

Please amend the claims as follows:

50. (Amended) A method of manufacturing a device comprising the steps of:  
forming a thin film transistor formed over a substrate having an insulating surface;  
forming an interlayer insulating film over the thin film transistor;  
forming an electrode over the interlayer insulating film;

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